

APR 11 2006

TROP, PRUNER & HU, P.C.
INTELLECTUAL PROPERTY LAW ATTORNEYS

8554 Katy Freeway, Suite 100
Houston, Texas 77024
Bus: (713) 468-8880
Fax: (713) 468-8883

Fax

To:	Examiner Heather Doty	From:	Timothy N. Trop
Company:	US Patent Office	Date:	April 11, 2006
Fax:	(571) 273-8300	Pages:	6 (including cover sheet)
Your Re:	10/807,836	Our Re:	ITL 1133US

Urgent
 For Review
 Please Comment
 Please Reply
 Confirm Receipt

MESSAGE:

• Notice: This information is intended to be for the use of the individual or entity named on this transmittal sheet. If you are not the intended recipient, be aware that any disclosure, copying, distribution, or use of the contents of this faxed information is prohibited. If you have received this facsimile in error, please notify the sender by telephone immediately so that arrangements can be made for the retrieval of the original document at no cost to you.

RECEIVED
CENTRAL FAX CENTER

APR 11 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant: Leonel R. Arana et al.
 Serial No.: 10/807,836
 Filed: March 24, 2004
 For: Microfabricated Hot Wire Vacuum Sensor

§
§
§
§
§
§
§
§
§
§

Art Unit: 2813
 Examiner: Heather Anne Doty
 Docket: ITL.1133US
 P19113
 Assignee: Intel Corporation

Mail Stop AF
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed March 20, 2006, please amend the above-referenced patent application as follows:

Date of Deposit: April 11, 2006
 I hereby certify that this document is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571/273-8300) on the date indicated above.
Cynthia L. Hayden
 Cynthia L. Hayden